



Attorney Docket No.: PATENT SSI-04001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

William Dale Jones

Serial No.: 10/680,783

Filed: October 6, 2003

For: **HIGH-PRESSURE PROCESSING
CHAMBER FOR A
SEMICONDUCTOR WAFER**

) Group Art Unit: 1763

) Examiner: Lund, Jeffrie Robert

) **Response to the final Office Action mailed
on January 30, 2006**

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Sir:

The Applicant submits this response to the final Office Action mailed on January 30, 2006:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.